## Curriculum vitae

## PERSONAL INFORMATION

First Name, Surname Oleksii Zavhorodnii

Date of Birth 1998-12-07 Citizenship Ukraine

E-mail nevermor464@gmail.com

Mobile Telephone +380509257946

**EDUCATION** 

2022 - Present Post-graduate course at the general physics department in Taras

Shevchenko National University of Kyiv

Physics faculty of Taras Shevchenko University of Kyiv, master in 2020-2022

physics of nanosystems (diploma with honours M22 №034028,

31.05.2022)

Physics faculty of Taras Shevchenko University of Kyiv, bachelor in 2016-2020

speciality "Physics and Astronomy" (diploma B20 №142087,

30.06.2020)

Ukrainian - C2, English – B2.

LANGUAGES

## SCIENTIFIC ACTIVITY

Number of Scientific Papers

Main Stream of Research Field of knowledge "Nature Sciences"

- defect engineering in semiconductor structures;

- machine learning for defect characterization.

Papers in Q1 and Q2 Journals 1. Olikh O., Lozitsky O., Zavhorodnii O. «Estimation for iron contamination in Si solar cell by ideality factor: Deep neural network approach», Progress in Photovoltaics: Research and Applications, 2022, vol.30. is.6. p. 648-660; https://doi.org/10.1002/pip.3539

> 2. Olikh, O., Zavhorodnii O. «Modeling of ideality factor value in structure», Journal of Physical Studies, 2020, vol. 24, is.4, p. 4701-1-4701-8; https://doi.org/10.30970/jps.24.4701

**International Conferences** 

1. Olikh, O., Zavhorodnii O. «Modeling of ideality factor value in silicon solar cells», XXII International Seminar on Physics and Chemistry of Solids, Lviv, Ukraine, Book of Abstracts, 2020. p. 77

2. Olikh O., Lozitsky O., Zavhorodnii O. «Deep-learning approach to the iron concentration evaluation in silicon solar cell», 9 European conference on renewable energy systems, Istanbul, Turkey, 2021, p.

22; ISBN: 978-605-86911-9-3

3. Olikh, O., Zavhorodnii O., Olikh Ya., Gapochenko S., Lyubchenko O., «Deep Learning-Based Impurity Evaluation: Targeting Silicon Solar Cells' Photovoltaic Parameters», IEEE 3rd KhPI Week on Advanced Technology (KhPIWeek), 2022

